

☐ Checkmate Entry
 ☐ Customer Entry
 ☐ POS Entry
 ☐ Sales Entry
 ☐ Misc
 ☐ Inventory
 ☐ Transfer
 ☐ Receipt
 ☐ RMA

☐ Misc
 ☐ Inventory
 ☐ 11/14

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	Type	Hits	Search Text	DBs	Time Stamp
2	11	BRS 12	((73/\$3.cor.) and ((through\$1hole or via\$1hole or plug or stud) with row) and (@ad<20040227 or @rlad<200402 USPAT: US-PGPUB	2004/09/27	
2	12	BRS 32	((mem or micro\$1electromechanical) and ((through\$1hole or via\$1hole or plug or stud) with row) and (@ad<2004 USPAT: US-PGPUB	2004/09/27	
7	13	BRS 0	((glass with substrate) and ((mem or micro\$1electromechanical) and ((through\$1hole or via\$1hole or plug or stud) USPAT: US-PGPUB	2004/09/27	
3	14	BRS 2	((glass with substrate) and ((through\$1hole or via\$1hole or plug or stud) with row) and (@ad<20040227 or @rla USPAT: US-PGPUB	2004/09/27	
3	15	BRS 8	(((through\$1hole or via\$1hole or plug or stud) with row) and (@ad<20040227 or @rlad<20040227) and (sens USPAT: US-PGPUB	2004/09/27	
3	16	BRS 18	((glass with substrate) and (((hole with row) and (@ad<20040227 or @rlad<20040227) and (sensor or sensi USPAT: US-PGPUB	2004/09/27	
4	17	BRS 18	((glass with substrate) and (((hole with row) and (@ad<20040227 or @rlad<20040227) and (sensor or sensi USPAT: US-PGPUB	2004/09/27	
6	18	BRS 2	((glass with substrate) and (accelerometer or ((accelerating or acceleration) with sensor)) and (@ad<20040227 or USPAT: US-PGPUB	2004/09/27	
3	19	BRS 3	((glass with substrate) and (accelerometer or ((accelerating or acceleration) with sensor)) and (@ad<20040227 or USPAT: US-PGPUB	2004/09/27	
6	20	BRS 6	((hole with row) and (@ad<20040227 or @rlad<20040227) and (mem or micro\$1electro\$1mechanical).ab. USPAT: US-PGPUB	2004/09/27	
6	21	BRS 6	((hole with (confined or confine or confining)) and (@ad<20040227 or @rlad<20040227) and (mem or micro\$1 USPAT: US-PGPUB	2004/09/27	
0	22	BRS 0	(((through\$1hole or via\$1hole or plug or stud) with row) and (@ad<20040227 or @rlad<20040227) and (mem o USPAT: US-PGPUB	2004/09/27	
0	23	BRS 0	(((through\$1hole or via\$1hole or plug or stud) with (confined or confine or confining) with (end or side)) and (@a USPAT: US-PGPUB	2004/09/27	
1	24	BRS 8	((glass with substrate) and (((through\$1hole or via\$1hole or plug or stud) with (confined or confine or confining) w USPAT: US-PGPUB	2004/09/27	
3	25	BRS 0	((capacity with shield) and (accelerometer.ab.) USPAT: US-PGPUB	2004/09/27	
0	26	BRS 11	((glass with substrate) and ((shield) and (accelerometer.ab.)) and (@ad<20040227 or @rlad<20040227) USPAT: US-PGPUB	2004/09/27	
2	27	BRS 10	"5545912" and (@ad<20040227 or @rlad<20040227) USPAT: US-PGPUB	2004/09/27	
0	28	BRS 1	((shield) and (accelerometer) and ("5545912" and (@ad<20040227 or @rlad<20040227)) USPAT: US-PGPUB	2004/09/27	
8	29	BRS 5	((shield) and ("5545912" and (@ad<20040227 or @rlad<20040227)) USPAT: US-PGPUB	2004/09/27	
0	30	BRS 29	(((((glass adi substrate) and (silicon with (and or ground or grounded))) and sensor) and (@ad<20040227 or @rlad< USPAT: US-PGPUB	2004/09/28	
6	31	BRS 11	((glass with substrate) and ((shield) and (accelerometer.ab.)) and (@ad<20040227 or @rlad<20040227) USPAT: US-PGPUB	2004/09/28	
1	32	BRS 32	((glass with substrate) and shield and ((sensor or sensing).ab.) and (@ad<20040227 or @rlad<20040227)) and USPAT: US-PGPUB	2004/09/28	
1	33	BRS 14	((glass with substrate) and shield and (((sensor or sensing) not (image or light or photo)).ab.) and (@ad<2004022 USPAT: US-PGPUB	2004/09/30	
3	34	BRS 15	((glass with substrate) and ((sensor or sensing or accelerometer) with (mount or mounted or mounting) with proces USPAT: US-PGPUB	2004/09/30	
2	35	BRS 0	((glass with substrate) and ((accelerometer) with (mount or mounted or mounting) with processor) and (@ad<200 USPAT: US-PGPUB	2004/09/30	
6	36	BRS 0	((glass with substrate) with pad) same. accelerometer) and (@ad<20040227 or @rlad<20040227) and (substrat USPAT: US-PGPUB	2004/09/30	
0	37	BRS 14	((glass with substrate) and (pad with accelerometer) and (@ad<20040227 or @rlad<20040227) and (substrate USPAT: US-PGPUB	2004/09/30	
8	38	BRS 21	((glass with substrate) and (pad with accelerometer) and (@ad<20040227 or @rlad<20040227) and (substrate cl USPAT: US-PGPUB	2004/09/30	
0	39	BRS 0	((glass with substrate) and (typical with (package or packaging) with accelerometer) and (@ad<20040227 or @rl USPAT: US-PGPUB	2004/09/30	
0	40	BRS 0	((glass with substrate) and (typical with (package or packaging) with accelerometer) and (@ad<20040227 or @rl USPAT: US-PGPUB	2004/09/30	
1	41	BRS 4	("6146917" "6352935" "6477901" "6507082").pn. USPAT: US-PGPUB	2004/09/30	
1	42	BRS 6	((glass with substrate) and (((package or packaging) with accelerometer) and (@ad<20040227 or @rlad<20040 USPAT: US-PGPUB	2004/09/30	
1	43	BRS 8	((glass with substrate with pad) same (typical or typically)) and (transducer or accelerometer) and silicon USPAT: US-PGPUB	2004/09/30	
5	44	BRS 17	((glass with substrate with pad) and ((transducer or accelerometer) with output) and silicon USPAT: US-PGPUB	2004/09/30	
1	45	BRS 17	((glass with substrate with pad) and ((transducer or accelerometer) with output) and silicon) and (@ad<2004022 USPAT: US-PGPUB	2004/09/30	
3	46	BRS 5	((transducer or accelerometer) with bonded) and (((bottom or lower) adi substrate) with pad) USPAT: US-PGPUB	2004/09/30	
1	47	BRS 23	((transducer or accelerometer)) and (((bottom or lower) adi substrate) with pad) USPAT: US-PGPUB	2004/09/30	
1	48	BRS 18	(((transducer or accelerometer)) and (((bottom or lower) adi substrate) with pad)) not (((transducer or accelero USPAT: US-PGPUB	2004/09/30	
0	49	BRS 7	((transducer or accelerometer or mem or microelectromechanical) and (((top or upper) adi substrate) with shield) USPAT: US-PGPUB	2004/09/30	
1	50	BRS 9	((transducer or accelerometer) and (((top or upper) adi substrate) with shield) USPAT: US-PGPUB	2004/09/30	
0	51	BRS 16	((transducer or accelerometer or mem or microelectromechanical) and (((top or upper) adi substrate) with shield) USPAT: US-PGPUB	2004/09/30	
0	52	BRS 0	((transducer or accelerometer or mem or microelectromechanical) and (((top or upper) adi substrate) with shield) USPAT: US-PGPUB	2004/09/30	
2	53	BRS 32	(((transducer or accelerometer or mem or microelectromechanical) with substrate with (shielded or shielding or sh USPAT: US-PGPUB	2004/09/30	
1	54				